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4/10/03
Shim H

PATENT APPLICATION
Do. No. 5484-48

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Byung-Sup SHIM and Young-Ho KIM

Serial No. 09/305,240

Examiner: Nadav, Ori

Filed: May 4, 1999

Group Art Unit: 2811

For: **OPEN DRAIN INPUT/OUTPUT STRUCTURE AND MANUFACTURING
METHOD THEREOF IN SEMICONDUCTOR DEVICE**

Confirmation No. 1838

BOX RCE
Assistant Commissioner for Patents
Washington, D.C. 20231

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TECHNOLOGY CENTER 2200
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REQUEST FOR CONTINUED EXAMINATION

Responsive to the Final Office Action, dated January 3, 2003, please amend the application as follows.